## **FORM PTO-1449**

## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional) 81864.0069 Application Number 10/541,096

**Applicant** 

Kyung-ku CHOI, et al.

Filing Date

June 27, 2005

Group Art Unit 2832

		U.S. PATEN	T DOCUMENTS	<u> </u>			
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DAT	
,	FO	REIGN PATE	ENT DOCUMEN	ITS			
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Transla YES	ation NO
	10-308320	11/17/98	JAPAN			Abstract	110
	09-035927	02/07/97	JAPAN			Abstract	
-	10-241935	09/11/98	JAPAN			Abstract	
	3-77575 (Corresponds to JP Published Application No. 61-178731)	12/11/91	JAPAN				х
	61-178731 (Corresponds to JP 3-77575)	08/11/86	JAPAN			Abstract	, _
	OTHER DOCUMEN	TS (Including Au	thor, Title, Date, Pe	rtinent Pages	, Etc.)		
	Y. Yamaguchi, et al., "Microfabrication J. Appln. Phys., Vol. 85, No. 11, June	n and characteris 1999, pp. 7919-	tics of magnetic thin- 7922	film inductors i	n the ultrahigh t	frequency re	gion"
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**EXAMINER** /Gary Harris/

**DATE CONSIDERED** 

02/21/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.